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Attorney Docket No.: 16869S-032100US Client Reference No.: E6171-01 EV

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Hidetoshi Nishiyama, et al.

Application No.:

Filed: Herewith

For: Method and Its Apparatus for Inspecting Particles or Defects of a

Semiconductor Device

Examiner: Unassigned

Art Unit: Unassigned

INFORMATION DISCLOSURE STATEMENT

UNDER 37 CFR §1.97 and §1.98

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

The references cited on attached form PTO/SB/08A-B are being called to the attention of the Examiner. Copies of the references are enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Applicant believes that <u>no fee is required</u> for submission of this statement, since it is being submitted prior to the first Office Action. However, if a fee is required, the

Commissioner is authorized to deduct such fee from Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,

When C Columbia

Robert C. Colwell Reg. No. 27,431

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U.S. PATENT DOCUMENTS								
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Examiner Initials *	Cite No. ¹	Number	Kind Cod		ame of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
	 	 						
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			FOREIG	N PATENT DOCU	MENTS		
Cite	Foreign Patent Document			Name of Patentee	Date of Publication of	Pages, Columns, Lines,	
No. ¹	Office ³	Number⁴	Kind Code ⁵ (<i>if known</i>)	or Applicant of Cited Document	Cited Document MM-DD-YYYY	Passages or Relevant	T ⁶
A1	JP	62-089336	5	Hitachi, Ltd.	04-23-1987		Abstract
A2	JP	5-273110		Mitsui Mining & Smelting Co., Ltd.	10-22-1993		Abstract
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	No.1	Cite No. ¹ Office ³	Office ³ Number ⁴ A1 JP 62-089336	Foreign Patent Document	Foreign Patent Document Name of Patentee	Cite No.¹ Office³ Number⁴ Kind Code⁵ (if known) A1 JP 62-089336 Hitachi, Ltd. Mame of Patentee or Applicant of Cited Document MM-DD-YYYY Hitachi, Ltd. 04-23-1987 Mitsui Mining & 10, 23, 1903	Foreign Patent Document No.1 Office3 Number4 Kind Code5 (if known) A1 JP 62-089336 Kind Code5 (if known) Mitsui Mining & 10 22 1993 Mitsui Mining & 10 23 1993

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PTO/SB/08B (08-00)

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STATEMENT BY APPLICANT				First Named Inventor	Nishiyama, Hidetoshi			
				Group Art Unit				
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Sheet	Sheet 2 of 2		Attorney Docket Number	16869S-032100US				

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	АЗ	STACY HALL, et al., "Yield Monitoring and Analysis in Semiconductor Manufacturing," VLSI Technology Seminar (SEMICON Kansai, 1997), pp. 4-42 thru 4-47.					
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